

Notice of References Cited	Application/Control No. 10/632,735	Applicant(s)/Patent Under Reexamination CALDWELL ET AL.	
	Examiner Brian K Andrea	Art Unit 3662	Page 1 of 1

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	C	US-5,394,238	02-1995	Mocker et al.	356/342
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.